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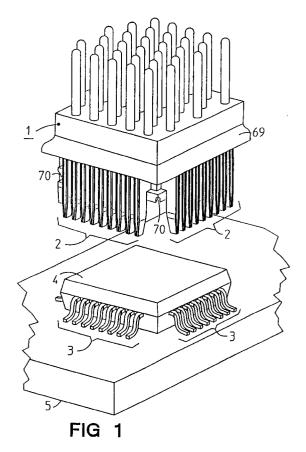
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(54)Connection appartus

A probe (1) for making electrical connections to the legs (3) of an already mounted integrated circuit (4) carries rows (2) of tapered wedges (8). The wedges within a row are spaced apart by an amount that corresponds to the width of the IC's legs. For n-many legs on a side of the IC there are n+1 corresponding wedges, which then have n-many intervening spaces. As the positioned probe is pressed down the spaces between the wedges receive the legs of the IC, and wedges become wedged between the IC's legs. Each wedge has left and right conductive surfaces (22) separated by an insulator (19.20.21). Each leg of the IC has a wedge to its left and a wedge to its right. Within the probe the right-hand conductive surface of the wedge to the left of a leg, and the left-hand conductive surface of the wedge to the right of that leg, are electrically connected together. Thus, the probe makes electrical contact to each leg in two places. The tapered wedges are of Ni-and Au-plated BeCu separated by acrylic adhesive and Kapton. Acrylic adhesive and Kapton are also used as the spacer between wedges. The rows of wedges (48-57) are cemented to a mantle (52). A lead frame (59) soldered to the butt end of the wedges connects opposing surfaces of adjacent wedges and makes the interconnection between the rows of wedges and an array of pins (61) in a pin block (60) at the top of the probe. Sticks of coplanar wedges are made by laminating layers of material in a press. The taper of the wedge tip arises from layers of shorter length in conjunction with a shaped surface in the laminating press. N+1 sticks are laminated together with intervening spacers to form a stack from which rows of n+1 wedges may be removed.



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CORRIGENDUM issued on 14.02.96



EUROPEAN SEARCH REPORT

Application Number EP 94 30 7845

Category	Citation of document with of relevant p	indication, where appropriate, meages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Inc.CL6)
Y	US-A-5 015 946 (B.JANKO) * abstract; figures 4,1 * * column 1, line 38 - column 2, line 2 * * column 3, line 5 - line 17 *		1,2	G01R1/04 H05K7/10 H01R13/26 H01R31/06
Y	PATENT ABSTRACTS OF JAPAN vol. 10 no. 244 (E-430) [2300] ,22 August 1986 & JP-A-61 074355 (HITACHI HOKKAI SEMIC.) 16 April 1986, * abstract *		1,2	
A	EP-A-O 305 951 (EVERETT/CHARLES) * abstract; figures 4,9,13-16 * * figures 19-21,36 * * column 5, line 18 - line 26 * * column 10, line 26 - line 34 * * column 17, line 27 - line 36 * * column 19, line 23 - line 28 * * column 20, line 11 - line 32 * * column 21, line 35 - line 41 * * column 22, line 1 - line 7 * * column 23, line 43 - line 51 * * column 25, line 55 - line 57 *		1,2	TECHNICAL FIELDS SEARCHED (Int.Cl.6) G01R H01R
A,P	EP-A-0 572 736 (ITT IND.) * abstract; figures 5,6 * * column 4, line 27 - line 38 *		1,2	
A	US-A-4 887 030 (K.M * abstract; figures * column 3, line 59 * column 4, line 31	1,2		
A	DE-A-27 52 749 (SIE * figures 1,5 *		1	
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	The present search report has b			
	Place of search	Date of completion of the search	F	Exeminer
	BERLIN CATEGORY OF CITED DOCUME		le underlying the	
Y : part	ticularly relevant if taken alone ticularly relevant if combined with an ument of the same category	E : earlier patent do after the filing d other D : document cited i L : document cited fr	nte n the application	•

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EUROPEAN SEARCH REPORT

EP 94 30 7845

Category	Citation of document with i	ndication, where appropriate, usages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Inc.CLG)
A	US-A-4 996 476 (M.E * column 3, line 56	MALYASNY ET AL.) i - column 4, line 2 *	1	
Х,Р	ELECTRONIC ENGINEER vol. 66, no. 809, N page 95 'Wedge tec density probing' * the whole documen	1,2		
X	WO-A-91 16737 (MINN MANUF.) * abstract; figures * figures 22-24 * * page 12, line 4 - * page 1, line 32 - * page 6, line 1 -	4,8-11,14,19 * page 13, line 13 * page 2, line 7 *	1	
E	WO-A-94 27344 (MINN MANUF.) * abstract; figures	s 1,5-8 *	1	
X,P	* page 4, line 24 -	page 5, line 8 * R.A.POPE ET AL.) 19 Ju	1 العالم	TECHNICAL FIELDS SEARCHED (Int.Cl.6)
X,P	WO-A-94 13034 (S.CR * page 10, paragrap figures 5,13,27-30 * page 11, paragrap	oh 2 - paragraph 3; *	1	
	The present search report has b	een drawn up for all claims Date of completion of the search	ŀ	Examiner
	BERLIN	3 November 199	5 Fri	tz, S
X : par Y : par doc	CATEGORY OF CITED DOCUME ticularly relevant if taken alone ticularly relevant if combined with an ument of the same category hoological background	E : earlier paten after the filli other D : document cit L : document cit	nciple underlying the t document, but publ ng date led in the application ed for other reasons	ished on, or